



COPY OF PAPERS
ORIGINALLY FILED

J. Jones
Bennett A.
H.B. 05/16/02
CP 3723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hu

Group Art Unit: 3723

Serial No.: 09/820,107

Examiner: W. Berry, Jr.

Filed: March 28, 2001

In Response to Office Action
Dated: January 17, 2002

For: Linear Chemical Mechanical Polishing Apparatus
Equipped with Programmable Pneumatic Support
- Platen and Method of Using

Attorney Docket No.: 67,200-364

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: April 17, 2002

Kathy Dixon

RECEIVED
MAY - 1 2002
TC 3700 MAIL ROOM

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed January 17, 2002,
please enter the following amendments and consider the following
remarks.